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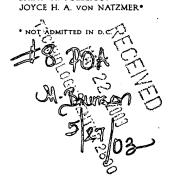
A PROFESSIONAL CORPORATION

1425 K STREET, N.W. SUITE 800 WASHINGTON, D.C. 20005

TELEPHONE (202) 783-6040 FACSIMILE (202) 783-6031 www.rothwellfigg.com

May 12, 2003

MARTHA CASSIDY, Ph.D.
ROBERT H. CAMERON
THOMAS E. MCKIERNAN*
MICHAEL J. MORAN, Ph.D.*
ANNE M. STERBA
LISA N. PHILLIPS*
LEIGH Z. CALLANDER*
C. NICHOLE GIFFORD
REGINA A. BAILEY
MONICA S. DAVIS*
PATRICK T. SKACEL
BRIAN S. ROSENBLOOM
TARA J. PATE
MONICA C. KITTS*
BRIAN A. TOLLEFSON*



G. FRANKLIN ROTHWELL E. ANTHONY FIGG BARBARA G. ERNST HARRY F. MANBECK, JR GEORGE R. REPPER STEVEN LIEBERMAN VINCENT M. DELUCA JOSEPH A. HYNDS ELIZABETH A. LEFF RICHARD WYDEVEN MARTIN M. ZOLTICK MINAKSI BHATT MICHAEL G. SULLIVAN SHARON L. DAVIS ROBERT B. MURRAY CARLA C. CALCAGNO

OF COUNSEL

JEFFREY L. IHNEN GLENN E. KARTA MARK I. BOWDITCH STEPHEN B. PARKER JOHN A. McCAHILL

> Commissioner of Patents and Trademarks Box PCT ATTN: RO/US Washington, D.C. 20231

> > Re:

International Patent Application No. PCT/US03/04503

Based on U.S. Serial No. 10/076,559, filed February 19, 2002 Title: THIN FILM ENCAPSULATION OF MEMS DEVICES

Applicant(s): Northrop Grumman Corporation, et al.

Our Reference: 2662-140.PCT

Dear Sirs:

In response to the Invitation to Correct Defects mailed **April 29, 2003**, the applicants respectfully submit copies of the executed General Powers of Attorney for the above-referenced application.

Respectfully submitted,

ROTHWELL, FIGG, ERNST & MANBECK

By:

Joseph A. Hynds

Registration No. 34,627 Attorney for Applicant

JAH/jjs Enclosure